



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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OK
2/25/03

Applicants: Yoo, Woo Sik
Assignee: WaferMasters, Inc.
Title: Method for Ultra-Thin Film Formation
Serial No.: 09/775,835 Filing Date: January 31, 2001
Examiner: Lisa A. Kilday Group Art Unit: 2829
Docket No.: M-8250 US

BOX AMENDMENT
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

Irvine, California
February 6, 2003

RECEIVED
FEB 20 2003
TECHNOLOGY CENTER 2800

RESPONSE TO NON-FINAL OFFICE ACTION

Dear Sir:

In response to the Office Action dated November 6, 2002, Applicants submit the following amendments and remarks.

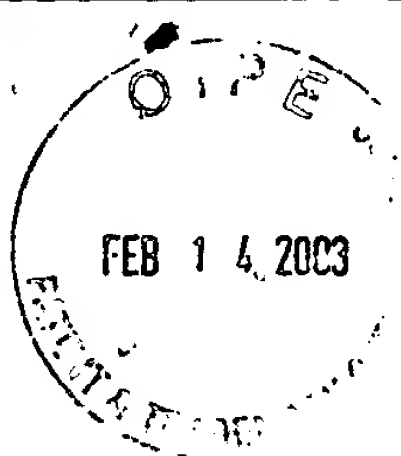
IN THE CLAIMS

The following is a clean version of the entire set of pending claims. In accordance with 37 C.F.R. §1.121(c)(1)(ii), Attachment A provides a marked-up version of the claims containing the newly introduced changes.

Please amend Claims 1, 4, 7, 10 and 14.

1. (Twice Amended) A method for forming a thin film on a semiconductor wafer comprising:
heating an internal environment of a process chamber to a steady-state processing temperature;
loading a semiconductor wafer into said internal environment of said process chamber;

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BOX AMENDMENTCommissioner For Patents
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Re: Applicant(s): Woo Sik Yoo
 Assignee: WaferMasters, Inc.
 Title: Method For Ultra-Thin Film Formation
 Serial No.: 09/775,835
 Examiner: Lisa A. Kilday
 Docket No.: M-8250 US

Filed: January 31, 2001
Group Art Unit: 2829

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (in duplicate);
- (3) Response to Office Action (9 pages).

- ☒ No additional fee is required.
☐ The fee has been calculated as shown below:

CLAIMS AS AMENDED

	Claims Remaining <u>After Amendment</u>		Highest No. Previously <u>Paid For</u>		Present <u>Extra</u>		<u>Rate</u>		<u>Additional Fee</u>
Total Claims	21	Minus	21	=	0	x	\$18.00	\$	0
Independent Claims	3	Minus	3	=	0	x	\$84.00	\$	0
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application							\$	
<input type="checkbox"/>	Fee for Request for Extension of Time							\$	

Total additional fee for this Amendment:

\$

- ☒ Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.
- ☒ Please charge our Deposit Account No. 50-2257 in the amount of \$
- ☒ Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total: \$**\$0**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on February 6, 2003.

Sandy Kim

February 6, 2003

Respectfully submitted,

Theodore P. Lopez
Attorney for Applicants
Reg. No. 44,881